

PATENT
8733.154.00

#12
11/26/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application of:

Jin JANG et al.

Group Art Unit: 1765

Application No.:

09/350,313

Examiner: R. Kunemund

Filing Date:

July 9, 1999

For:

Method of Crystallizing Amorphous Silicon Layer and
Crystallizing Apparatus Thereof

NOTICE OF APPEAL

RECEIVED

NOV 26 2001

TC 1700

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants hereby appeal to the Board of Appeals from the decision dated May 17, 2001.

The items checked below are appropriate:

☒ A Petition for an Extension of Time Under 37 C.F.R. § 1.136 was filed on August 20, 2001.

☐ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.

☒ A Petition for Extension of Time for filing the Notice of Appeal is attached.

☒ Fees: \$1,130.00

\$320 for the Notice of Appeal and \$810.00 for the Extension of Time is attached.

☐ Charge to Deposit Account No. 50-0911 (an additional copy of this notice is enclosed herewith).

☐ Please charge any additional fees or credit any overpayment of fees required for filing the Notice of Appeal to Deposit Account No. 50-0911. A duplicate copy of this Notice is enclosed.

☒ If this notice is not considered timely filed by the U.S. Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. § 1.136, and any additional fees required under 37 C.F.R. § 1.136 for any necessary extension of time may be charged to Deposit Account No. 50-0911.

Respectfully submitted,

LONG ALDRIDGE & NORMAN, LLP

By

Song K. Jung
Reg. No. 35,210

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Void date: 11/19/2001 BNGUYEN1
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